

OGOSH25USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re the Application of: )  
 ) Examiner:  
 Yuichiro Shindo et al. )  
 ) Group Art Unit:  
 Application No.: )  
 )  
 Corresponding International Filing No.: )  
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 Filed: Herewith )  
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 For: HIGH PURITY COPPER )  
 SULFATE AND METHOD )  
 FOR PRODUCTION THEREOF )

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Please amend the above-identified patent application as follows.

**Amendments to the Specification** begin on page two of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page three of this paper.

**Remarks** begin on page seven of this paper.